

Abstracts

Multi-layer spiral inductors in a high-precision, fully-planar MCM-D process

M. Gouker, K. Konistis, J. Knecht, L. Kushner and L. Travis. "Multi-layer spiral inductors in a high-precision, fully-planar MCM-D process." 2000 MTT-S International Microwave Symposium Digest 00.2 (2000 Vol. II [MWSYM]): 1055-1058.

The precision MCM process described in this paper has several performance enhancing features not found in other reported MCM processes. The process enables the fabrication of inductors with orders of magnitude greater inductance than other packaging techniques for the same area on the MCM.

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